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MEM 00-1100 (2808.1)
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: John D. Holder, et al.
Art Unit: 1765
Serial No.: 10/004,961
Filed: December 3, 2001
Confirmation No.: 7824
For: PROCESS FOR MONITORING THE GASEOUS
ENVIRONMENT OF A CRYSTAL PULLER FOR
SEMICONDUCTOR GROWTH

April 1, 2003

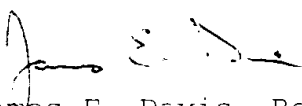
TO THE COMMISSIONER FOR PATENTS,
SIR:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicants submit copies of the references listed on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

This Supplemental Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.97(b) in that Applicants believe that it is being filed prior to the mailing date of the first Office action on the merits. Accordingly, neither a statement nor fee under 37 C.F.R. §1.97(c) or (d) is required. However, if the mailing date of the first Office action on the merits in fact precedes the filing of this Supplemental Information Disclosure Statement, the Commissioner is hereby authorized to charge any fees incurred to Deposit Account No. 19-1345.

Respectfully submitted,


James E. Davis, Reg. No. 47,516
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

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**SUPPLEMENTAL
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

Application Number	10/004,961
Filing Date	December 3, 2001
Confirmation Number	7824
First Named Inventor	John D. Holder
Group Art Unit	1765
Examiner Name	Matthew A. Anderson
Attorney Docket No.	MEMC 00-1100 (2808.1)

Sheet

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of

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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		
	9	5,979,225		Zhou	11-09-1999

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office	Number ⁴	Kind Code ² (if known)			
	10	JP	53074482		Nippon Steel Corp.	07-01-1978	A
	11	JP	61275187		Toshiba Ceramics Co., Ltd.	12-05-1986	A
	12	JP	62113789		NEC Corp.	05-25-1987	A

OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
	13	International Search Report from the European Patent Office dated July 8, 2002	

Examiner
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Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached or place an "A" here if English language abstract is attached.

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